

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?: NONE
Title:: POLYGON-TYPE SEMICONDUCTOR
DETECTOR FOR USE IN HIGH-SPEED
X-RAY CT, AND MANUFACTURING
METHOD THEREFOR
Attorney Docket Number:: 218866US2
Total Drawing Sheets:: 1

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Masaki
Family Name:: MISAWA
City of Residence:: Ibaraki
Country of Residence:: Japan
Street of Mailing Address:: 4-407-106 Matsushiro, Tsukuba
City of Mailing Address:: Ibaraki
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 305-0035

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2001-023141	Japan	01/31/01	YES

ASSIGNMENT INFORMATION

Assignee Name:: National Inst. of Advanced Ind. Science
and Tech.
Street of Mailing Address:: 3-1, Kasumigaseki 1-chome, Chiyoda-ku

City of Mailing Address::
Country of Mailing Address::

Tokyo
Japan

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